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|---|---|--|--|--|--|
| Digital: Noise Variance Defects Energy Compactness | | | | | |
| Analog: | | | | | |
| Signal transit delays Charging/discharging delays Noise | | | | | |
| Linearity Power Gain Parasitics | MEMS has its own additional set arising from 3D and mechanical properties and their interactions with others | | | | |
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| SWOT | | | | | |
|----------------------------|-------------------------------------|--|---|---|--|
| | Strength | Weakness | Opportunity | Threat | |
| Graphene | Electrostatics, ideal mobility | Charge outside graphene, Resistance to dimensionality, No BGap | 3D integration, Thz nonlinearities, Broad λ photoabsorption | Contact R, Reproducibility | |
| Nanotubes | Electrostatics, high mobility | Variable bandgap, metal & semiconductor | Conductiivty, mechanical strength | Contact R, variability, no substrate | |
| Tunnel transistor | Only works at small spacing | Tunneling is size dependent, high C | High current | Variability, Contact density | |
| Mott transistor | Insulator to conduction transition | Poor mobility | New principle, size independence | Contact R, region transitions | |
| BISFET | Potential low energy | Coherence and negative R | New principle | RT, variability, | |
| Nanowires | Electrostatics | Surfaces | New fabrication techniques | Contact R, Variability | |
| III-V's | Bulk mobility | Surface states | New materials | Variability, Poor inversion, | |
| Topological Insulators | Surface conduction, bulk insulation | Low T, Small bandgap materials | New physical mechanisms | Small bandgap, low currents, Low T | |
| Electrochem Memory | Atomic scale cond path | Stochasticity, interfaces, energy | Simple structure | Randomness, high field traps | |
| Electromechanical | Mechanics, zero off Curr | Size, cycling | Configurability, memory, dynamic | Stiction, reproducibility, | |
| Spin-Semicond | No charge movement | Coherence lengths, temp | Less soft errors | Not RT, too much energy in conversions, loss | |
| Spin transfer, magnetics | Speed, | Current, integration | Non-volatile, soft error immunity | Density, robustness in large # of thin films | |
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New Technology Challenges

When the answer to improvement in a subset of properties is negative in a fundamental form at the lowest strata, the conclusion is easy.

When it passes that test, it is much harder.

The Challenge is that if the system use is of many components interacting together Global Optimization versus Local Optimization under system constraints is a hard problem that requires a thorough design incorporating the abstractions.

Example: In late 70's, IBM stayed with bipolar because CMOS was too slow. The answer under power constraints was in

architecture (similar to the multicore today).

So, system-scale design very critical.

Today: Look at ARM versus Intel. There are x10-100 more ARM processors in the world